Search	earch Notes		

Application/Control No.	Applicant(s)/Patent under Reexamination
10/052,870	SHI ET AL.
Examiner	Art Unit
Jason M. Perilla	263/16

SEARCHED				
Class	Subclass	Date	Examiner	
375	219	6/15/2005	JP	
	316	6/15/2005	JP	
	324	6/15/2005	JP	
	344	6/15/2005	JP	
	345	6/15/2005	JP	
	346	6/15/2005	JP	
455	130	6/15/2005	JP	

INI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East USPAT USPGPUB EPO JPO	6/15/2005	JP
Inventor Name Search EAST/EDAN	6/15/2005	JP